

<b>Notice of References Cited</b>		Application/Control No. 10/531,942	Applicant(s)/Patent Under Reexamination Li, Yi	
		Examiner Jeong S. Park	Art Unit 2454	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-6,574,663	06-2003	Bakshi et al.	709/223
*	B US-7,188,151	03-2007	Kumar et al.	709/217
*	C US-2002/0083193	06-2002	Terefenko, Henry	709/238
*	D US-2002/0147661	10-2002	Hatakama et al.	705/26
*	E US-2003/0088876	05-2003	Mao et al.	725/91
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
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**FOREIGN PATENT DOCUMENTS**

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N					
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**NON-PATENT DOCUMENTS**

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